



501.40830X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: T. HIROI et al

EXPEDITED PROCEDURE

Serial No.: 09/986,299

Filed: November 8, 2001

For: Pattern Inspection Method And Apparatus

Art Unit: 2625

Examiner: J. Strege

Entered via  
RCE 10-14-05

**AMENDMENT AFTER FINAL REJECTION**

Mail Stop: Box AF Amendment (Fee)  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

September 16, 2005

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application, in response to the Office Action dated May 16, 2005. The amendments are listed below and set forth on the following pages.

Amendments to the Specification;

Amendments to the Claims; and

Remarks are included following the amendments.